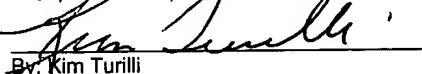




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Patent  
Atty. Docket: H37-091 DIV

CERTIFICATE OF MAILING  
I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 24, 2003:

  
By: Kim Turilli  
Dated: October 24, 2003

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : J. Schmitt  
Serial No. : 09/824,936  
Filing Date : April 3, 2001  
For : PLASMA REACTOR FOR THE TREATMENT  
OF LARGE SUBSTRATES  
Examiner : A.M. Crowell  
Group Art Unit : 1763

**Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

### SUPPLEMENTAL AMENDMENT

Sir:

In supplement to the Amendment filed October 2, 2003, attached to this Amendment please find a copy of Japanese reference JP 08-186094 to Hanada, along with a translated abstract and mechanized translation of the entire reference.

Favorable consideration is respectfully requested.

Respectfully submitted,



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Reg. No. 28,643  
Attorney for Applicants  
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Dated: October 24, 2003

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